

**Search Notes**

Application No.

10/749,659

Examiner

Jennifer M. Kennedy

Applicant(s)

WANG, ZHONGZE

Art Unit

2812

**SEARCHED**

Class	Subclass	Date	Examiner
257	347-354	9/15/2004	JMK
438	149, 151	9/15/2004	JMK
update		10/27/2004	JMK
438	455, 459	10/27/2004	JMK
update		2/3/2005	JMK

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
257	347-354	2/3/2005	JMK
438	149, 151	2/3/2005	JMK
438	455, 459	2/3/2005	JMK

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East text	9/15/2004	JMK
consulted parent cases	9/15/2004	JMK
consulted with Erik Kielin to confirm that nitridization with NO or N2O would necessarily form a silicon oxynitride layer	10/27/2004	JMK
update EAST text	10/27/2004	JMK
update	2/3/2005	JMK